

In re application of

Confirmation No. 4559

Yasushi ISAYAMA et al.

Attorney Docket No. 2003 1051

Serial No. 10/627,684

Group Art Unit 1742

Filed July 28, 2003

Examiner Harry Wilkins

RESPONSE UNDER 37.CFR1.116

EXPEDITED PROCEDURE
EXAMINING GROUP

METHOD OF MEASURING THE CONCENTRATION
OF A LEVELER IN A PLATING LIQUID, AND
METHOD OF AND APPARATUS FOR
MANAGING A PLATING LIQUID

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

AMENDMENT AFTER FINAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated March 2, 2006, the period for response to which having been extended by three months to September 5, 2006, please amend the above-identified application as follows.